

Search Notes

Application/Control No.

10/767,167

Examiner

Matthew L. Reames

Applicant(s)/Patent under
Reexamination

MIURA ET AL.

Art Unit

2891

SEARCHED

Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Mach-Zender Inforemeter same silicon (EAST)	10/8/2007	MLR